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					APPLICANT Stephen D. HSU, et al.				
		(PT	O-1449)		FILING DATE July 25, 2003	GROUP 2825			
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

"Spatial Frequency Doubling Lithography (SFDL) of Periodic Structures for Integrated Optical Circuit Technology", Tanya E. Jewell and Donald L. White. Journal of Lightwave Technology, Vol. 7, No. 9, September 1989

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06/29/2006

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/Suchin Parihar/